

10538727

JC17 Rec'd 13 JUN 2005
PATENTAttorney Docket :
33082 M 256

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Hideo SHITE

International Application No.: PCT/JP2003/16154

International Filing Date: December 17, 2003

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: COATING PROCESS APPARATUS AND
COATING FILM FORMING METHODINFORMATION DISCLOSURE STATEMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicant is enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents noted in the specification and International Search Report being filed herewith. Copies of all non-U.S. cited documents are enclosed.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By:



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June 13, 2005

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /Y.T.

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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT		ATTY. DOCKET 33082M256	SERIAL NO. 10538727 To Be Assigned
		APPLICANT: Hideo Shite	
		FILING DATE Herewith	GROUP ART UNIT To Be Assigned

U.S. PATENT DOCUMENTS

*Examiner's Initials	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
AA	2001/0028920	10/11/01	Ito et al.			
AB						
AC						
AD						
AE						
AF						
AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO
AH	2001-189266	7/10/01	Japan			Abstract
AI	09-017722	1/17/97	Japan			Abstract
AJ	2002-110517	4/12/02	Japan			X
AK	06-099125	4/12/94	Japan			Abstract
AL	64-039023	2/9/89	Japan			Abstract
AM						
AN						
AO						
AP						

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

AQ	
AR	
AS	
AT	

EXAMINER: DATE CONSIDERED:

/Yewebdar T Tadesse/

11/21/2008

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /Y.T.T.